

Application/Control No.	Applicant(s)/Patent under Reexamination	)/Patent under tion	
10/042,166	LIN ET AL.		
Examiner	Art Unit		
Hong Cho	2616		

SEARCHED				
Class	Subclass	Date	Examiner	
370	443, 444, 449, 348	4/27/2006	нс	
710	109-113	4/27/2006	нс	
above	UPDATED	8/2/2006	нс	
above	UPDATED	1/18/2007	нс	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
370	348	8/2/2006	нс	
	444			
	ence search printout	1/18/2007	нс	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
consulted Chau Nguyen for search help	4/26/2006	нс		
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